

## RESPONSE UNDER 37 CFR 1.116 **EXPEDITED PROCEDURE EXAMINING GROUP 1765**

PATENT APPLICATION Do. No. 4591-226 Client No. IE10177-US

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Do-Hyung KIM, et al.

Serial No.

10/080,884

Examiner:

Deo, Duy Vu Nguyen

Confirmation No.

6557

Filed:

February 22, 2002

Group Art Unit: 1765

For:

METHOD OF FORMING A DEVICE ISOLATION TRENCH IN AN

INTEGRATED CIRCUIT DEVICE

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## **AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR 1.116**

Responsive to the Final Office Action, dated May 11, 2004, please amend the application as follows.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.